

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q90565

Hong-sik PARK, et al.

Appln. No.: 10/552,351

Group Art Unit: 2812

Confirmation No.: 2396

Examiner: Elias ULLAH

Filed: October 7, 2005

For: METHOD OF FABRICATING SEMICONDUCTOR PROBE WITH RESISTIVE TIP

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of June 1, 2007, please consider Applicants' remarks as follows.

**TABLE OF CONTENTS**

REMARKS.....	2
--------------	---